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Bib Data Sheet

CONFIRMATION NO. 7460

|                                    |   |                     |                               |   |
|------------------------------------|---|---------------------|-------------------------------|---|
| <b>SERIAL NUMBER</b><br>10/511,607 | <b>FILING OR 371(c)<br/>DATE</b><br>11/04/2004<br><b>RULE</b> | <b>CLASS</b><br>118 | <b>GROUP ART UNIT</b><br>1734 | <b>ATTORNEY<br/>DOCKET NO.</b><br>260615US2XPCT |
|------------------------------------|---|---------------------|-------------------------------|---|

**APPLICANTS**

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**\*\* CONTINUING DATA \*\*\*\*\***

This application is a 371 of PCT/JP03/06331 05/21/2003

**\*\* FOREIGN APPLICATIONS \*\*\*\*\***

JAPAN 2002-164151 06/05/2002

|   |                                      |                                 |                               |                                    |
|---|--------------------------------------|---------------------------------|-------------------------------|------------------------------------|
| Foreign Priority claimed<br><input type="checkbox"/> yes <input type="checkbox"/> no  | <b>STATE OR<br/>COUNTRY</b><br>JAPAN | <b>SHEETS<br/>DRAWING</b><br>16 | <b>TOTAL<br/>CLAIMS</b><br>33 | <b>INDEPENDENT<br/>CLAIMS</b><br>7 |
| 35 USC 119 (a-d) conditions<br>met <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after<br>Allowance |                                      |                                 |                               |                                    |
| Verified and<br>Acknowledged  | Examiner's Signature                 | Initials                        |                               |                                    |

**ADDRESS**

22850

**TITLE**

Method and device for cleaning raw material gas introduction tube used in cvd film forming apparatus

|  |   |  |
|--|---|--|
| <b>FILING FEE<br/>RECEIVED</b><br>2358 | FEES: Authority has been given in Paper<br>No. _____ to charge/credit DEPOSIT ACCOUNT<br>No. _____ for following: | <input type="checkbox"/> All Fees<br><input type="checkbox"/> 1.16 Fees ( Filing )<br><input type="checkbox"/> 1.17 Fees ( Processing Ext. of<br>time )<br><input type="checkbox"/> 1.18 Fees ( Issue )<br><input type="checkbox"/> Other _____<br><input type="checkbox"/> Credit |
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